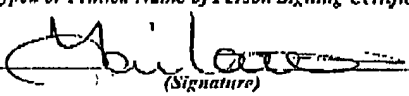


<b>CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)</b>			Docket No.
Applicant(s): Bum-Gee BAEK, et al.			YOM-0051
Application No. 10/653,556	Filing Date 9-2-2004	Examiner Yin, Shouxiang	Group Art Unit 2811
Invention: CONTACT STRUCTURE OF SEMICONDUCTOR DEVICE, MANUFACTURING METHOD THEREOF, THIN FILM TRANSISTOR ARRAY PANEL INCLUDING CONTACT STRUCTURE, AND MANUFACTURING METHOD THEREOF			
<p>Combined Amendment &amp; Petition for Extension of Time (2 pages), Amendment (2 pages), Limited Recognition Under 37 C.F.R §10.9(b) (1page) and Authorization to debit and/or credit Deposit Acct. No. 06-1130 - One Month Extension of Time Fee</p> <p>I hereby certify that this (Identify type of correspondence)</p> <p>is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. 703-872-9306)</p> <p>on August 17, 2004 (Date)</p> <p>Tammie Lanthier (Typed or Printed Name of Person Signing Certificate)</p> <p> (Signature)</p> <p>RECEIVED CENTRAL FAX CENTER AUG 17 2004</p> <p>OFFICIAL</p> <p>Note: Each paper must have its own certificate of mailing.</p>			

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Applicant: BUM-GEF BAEK, ET AL. )  
Serial No.: 10/653,556 ) Group Art Unit: 2811  
Filed: September 2, 2003 ) Examiner: Hu, Shouxiang  
For: CONTACT STRUCTURE OF )  
SEMICONDUCTOR DEVICE, )  
MANUFACTURING METHOD THEREOF, )  
THIN FILM TRANSISTOR ARRAY PANEL )  
INCLUDING CONTACT STRUCTURE, AND )  
MANUFACTURING METHOD THEREOF )

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the restriction requirement mailed on July 15, 2004, the Applicants submit the following election for further prosecution on the merits:

Election:

The Applicants hereby provisionally elect Species 1 of Group I, as illustrated in Figures 1-8. The presently pending claims readable upon Species 1 of Group I include claims 1-4 and 8-15.